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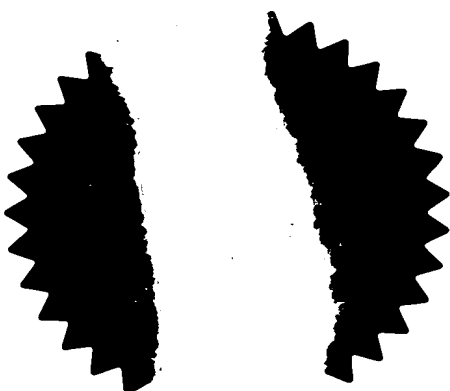
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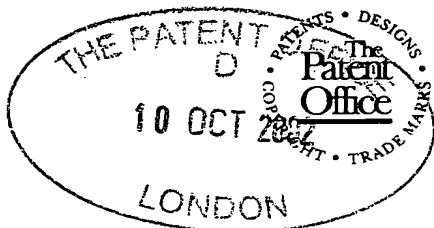
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Dated 18 September 2003



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P01/7700 0.00-0223684.2

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Cardiff Road
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1. Your reference

NIS/DC/38752

2. Patent application number

(The Patent Office will fill in this part)

0223684.2

10 OCT 2002

3. Full name, address and postcode of the or of each applicant (underline all surnames)

Tesla Engineering Ltd.,
Water Lane
Storrington
Sussex RH20 3EA

Patents ADP number (if you know it)

If the applicant is a corporate body, give the country/state of its incorporation

GB

4. Title of the invention

Gradient Coil Structure for Magnetic
R sonance Imaging.

5. Name of your agent (if you have one)

fJ Cleveland

"Address for service" in the United Kingdom to which all correspondence should be sent (including the postcode)

40-43 Chancery Lane
London WC2A 1JQ

Patents ADP number (if you know it)

07368855001

6. If you are declaring priority from one or more earlier patent applications, give the country and the date of filing of the or of each of these earlier applications and (if you know it) the or each application number

Country

Priority application number
(if you know it)

Date of filing
(day / month / year)

7. If this application is divided or otherwise derived from an earlier UK application, give the number and the filing date of the earlier application

Number of earlier application

Date of filing
(day / month / year)

8. Is a statement of inventorship and of right to grant of a patent required in support of this request? (Answer 'Yes' if:

Yes

- a) any applicant named in part 3 is not an inventor, or
 - b) there is an inventor who is not named as an applicant, or
 - c) any named applicant is a corporate body.
- See note (d))

Patents Form 1/77

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Continuation sheets of this form

Description

7

Claim(s)

2

Abstract

10

please
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Drawing(s)

4

a 4



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Priority documents

Translations of priority documents

Statement of inventorship and right to grant of a patent (Patents Form 7/77)

Request for preliminary examination and search (Patents Form 9/77)

1

Request for substantive examination (Patents Form 10/77)

Any other documents
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11.

I/We request the grant of a patent on the basis of this application.

fJ Cleveland
Signature



Date

10 October 2002

12. Name and daytime telephone number of person to contact in the United Kingdom

N I Smith

020 7405 5875

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Gradient Coil Structure for Magnetic Resonance Imaging

This invention relates to magnetic coil structures and in particular relates to gradient coil structures for use in magnetic resonance imaging and
5 Spectroscopy (MRIS).

There are known MRIS systems which comprise a plurality of concentric coils which are located around a region within which a subject can be located. The coils include an outermost DC coil which is used to provide a strong constant magnetic field, an inner RF coil arrangement which is arranged
10 concentrically within the DC coil, and a gradient coil assembly which is located between the inner RF and the outer DC coil. The gradient coil assembly is arranged to generate a time varying magnetic field which causes the response frequency and phase of the nuclei of the patient to depend upon their positions within the field.

15 Arrangements of this type are known where the coils are cylindrical. The gradient coil assemblies usually consist of a set of three coils referred to as the X, Y and Z gradient coils. An unshielded gradient may be formed by winding a pattern of conductors on the surface of a cylinder. Commonly however, each of the gradient coils is shielded by another pattern of conductors
20 wound on another cylinder which surrounds the gradient coils.

More recently, alternative magnet geometries have been developed. In

one such arrangement the magnet comprises two substantially distinct assemblies separated by a gap. The dominant magnetic field is generated between these assemblies and this type of configuration is commonly referred to as a transverse field magnet. The magnetic field may be generated by a permanent magnet, a resistive electromagnet or a superconducting magnet. The subject to be imaged is placed between the magnet assemblies. In such arrangements a cylindrical gradient coil configuration is no longer appropriate. A typical geometry of such a gradient coil comprises two substantially planar discs located above and below the subject being imaged. The discs can optionally incorporate additional shield windings.

Shielding coils for MRIS in transverse field configurations can be constructed substantially independently from the main coils which produce the homogeneous magnetic field. Figure 1a shows a cross sectional view of a known configuration in which the shielding coils 10 are connected in series with the main coils 11 at a single pair of terminals. Figure 1b shows the winding pattern for the main X gradient coil and the shielding coil. This configuration produces good shielding characteristics especially if the shielding coil is larger in diameter than the main coil. However, the arrangement results in a very large diameter assembly. The turns at the perimeter of the main coil and shield coil substantially cancel each other magnetically, but they are costly in terms of inductance and resistance; therefore the whole assembly is

relatively inefficient.

It has been proposed to truncate the outer parts of such a coil configuration by in effect discarding the windings of each beyond a certain radius and linking many of the partial turns at the main coil so formed to the partial turns of the shielding coil. It has also been proposed to make the main coil planar and the shielding coils substantially concave or substantially conical when viewed from the imaging region. This type of known arrangement is illustrated in Figure 2a of the drawings where the planar main coils are shown at 14 and the conical shielding coils at 15. Figure 2b shows the winding patterns of the main gradient coil and the conical shielding coil. An arrangement of this type is described in WO 02/27345 and WO 02/27346.

This type of configuration results in a very compact coil. However, it involves a design compromise. As the shielding coil no longer extends beyond the main coil its effectiveness is reduced and substantial leakage fields can be created. These may induce eddy currents in conductive parts of the magnet. Such eddy currents may generate additional and deleterious time-varying magnet fields in the imaging region. Furthermore if the main magnetic field is produced by a superconducting coil, then the eddy currents may also generate dissipation in the cryogenic structure of the magnet thereby degrading its cryogenic performance.

The present invention has been developed in order to reduce these

problems.

According to the present invention there is provided a gradient coil structure for use in MRI apparatus, said coil structure comprising a main gradient coil and a shielding coil, said shielding coil having a portion thereof
5 disposed outwardly from the main gradient coil and said coils being configured so that in a peripheral region relative to the imaging volume, the coils are almost coincident. Preferably some net current flows in the coils of the coincident region.

The coils in the coincident region may extend forwardly at an angle to
10 the remainder of the main coil so that the main coil appears concave from the imaging volume. The shielding coil may be generally conical. The central region of the main coil may be planar and the angle between the coincident region and central region of the main coil may be obtuse.

Arrangements in accordance with the present invention provide
15 improved shielding performance. Because of their near coincidence currents at the main and shielding coil become substantially interchangeable in the region of coincidence and current may be reassigned between the coils to meet manufacturing considerations.

The invention will be described now by way of example only with
20 particular reference to the accompanying drawings.

In the drawings:

Figure 1a is a cross sectional view of a known planar gradient coil assembly;

Figure 1b is plan view showing the winding patterns of the main and shielding coils of Figure 1a;

5 Figure 2a is a cross sectional view of another know gradient coil assembly;

Figure 2b is a view projected onto a plane showing the winding patterns of the main and shielding coils of Figure 2a;

Figure 3a is a cross sectional view of a gradient coil assembly in
10 accordance with the present invention;

Figure 3b is a view projected onto a plane showing the winding patterns of the main and shielding coil of Figure 3a; and

Figure 4a is a schematic view illustrating an MRIS system incorporating a gradient coil assembly in accordance with the present invention.

15 Referring to Figure 3a, a gradient coil assembly in accordance with an embodiment of the present invention comprises a main coil 20 and a shielding coil 21. It will be appreciated that Figure 3a in fact shows two gradient coil assemblies, one above and one below the imaging region 22. The main coil 20 has a central planar region 24 and a conically extending outer region 25. The
20 gradient coil is generally conical and in its outer region is substantially coincident with the conical portion 25 of the main coil. The winding patterns

for the main gradient coil and shielding coil are shown in Figure 3b.

Thus, it can be seen that the shielding coil and the main coil are effectively jointly extended forward from the planar front face 24 of the main coil and are substantially coincident in this region 25. For optimal shielding
5 some net current is required to flow in the extended region 25. Because of the near coincidence, the roles of the main coil and the shielding coil become effectively interchangeable in the extended region and current may be reassigned between the two coils as manufacturing conditions require.

The main and shielding coils are designed so that their respective
10 conductors meet at the edges of extended region where they can be linked appropriately. It should be noted that the main coil is concave when viewed from the imaging region and the shielding coil is also concave but to a greater degree.

It has been found that relative to, for example, the prior art arrangement
15 in Figure 2, the configuration of Figure 3 generates similar fields in the imaging region, but has substantially improved shielding efficiency. The leakage fields are reduced by up to a factor of 2 which will result in roughly a four-fold reduction in the contribution to cryogenic heat-load. It is also likely that image degradation due to eddy currents will be substantially reduced.

20 The assembly shown in Figure 3 of the drawings is for the particular case of an X gradient assembly and its associated conical shielding coil. It will

be appreciated by those skilled in the art that a Y gradient assembly would be of similar construction but rotated by 90° around the axis of the cone. It will also be appreciated that a Z gradient coil assembly can be constructed using similar principles, but in this case the conductors are substantially circular and coaxial with the cone.

Figure 4 of the drawings illustrates how the X gradient coil assembly of Figure 3 can be incorporated into an MRIS apparatus. In Figure 4 the upper and lower magnet assemblies of an MRIS apparatus are shown at 30 and 31 with supports 32 extending therebetween. It will be appreciated that the assemblies 30 accommodate coils which generate the substantially homogeneous magnetic field required for MRIS together with the RF fields. Each magnet assembly 30, 31 has a conical shaped recess 34 which accommodates a gradient coil assembly 35 of the type described with reference to Figure 3.

CLAIMS

1. A gradient coil structure for use in MRI apparatus, said coil structure comprising a main gradient coil and a shielding coil, said shielding coil having
5 a portion thereof disposed outwardly from the main gradient coil and said coils being configured so that in a peripheral region relative to the imaging volume, the coils are almost coincident.
2. A gradient coil structure according to claim 1 wherein, in use, some net
10 current flows in the coils of the coincident region.
3. A gradient coil structure according to claim 1 or claim 2 wherein, the coils in the coincident region extend forwardly at an angle to the remainder of the main coil so that the main coil appears concave from the imaging volume.
15
4. A gradient coil structure according to any preceding claim wherein the shielding coil is generally conical.
5. A gradient coil structure according to any preceding claim wherein the
20 central region of the main coil is planar and the angle between the coincident region and central region of the main coil is obtuse.

6. A gradient coil structure substantially as hereinbefore described with reference to and as shown in Figure 3 of the accompanying drawings.

7. An MRIS apparatus including a gradient coil structure according to any
5 preceding claim.

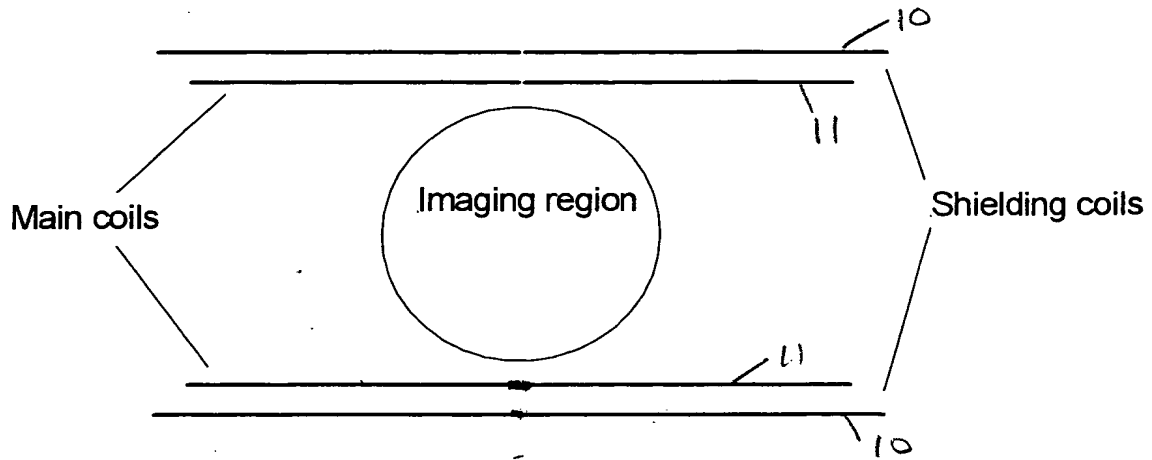
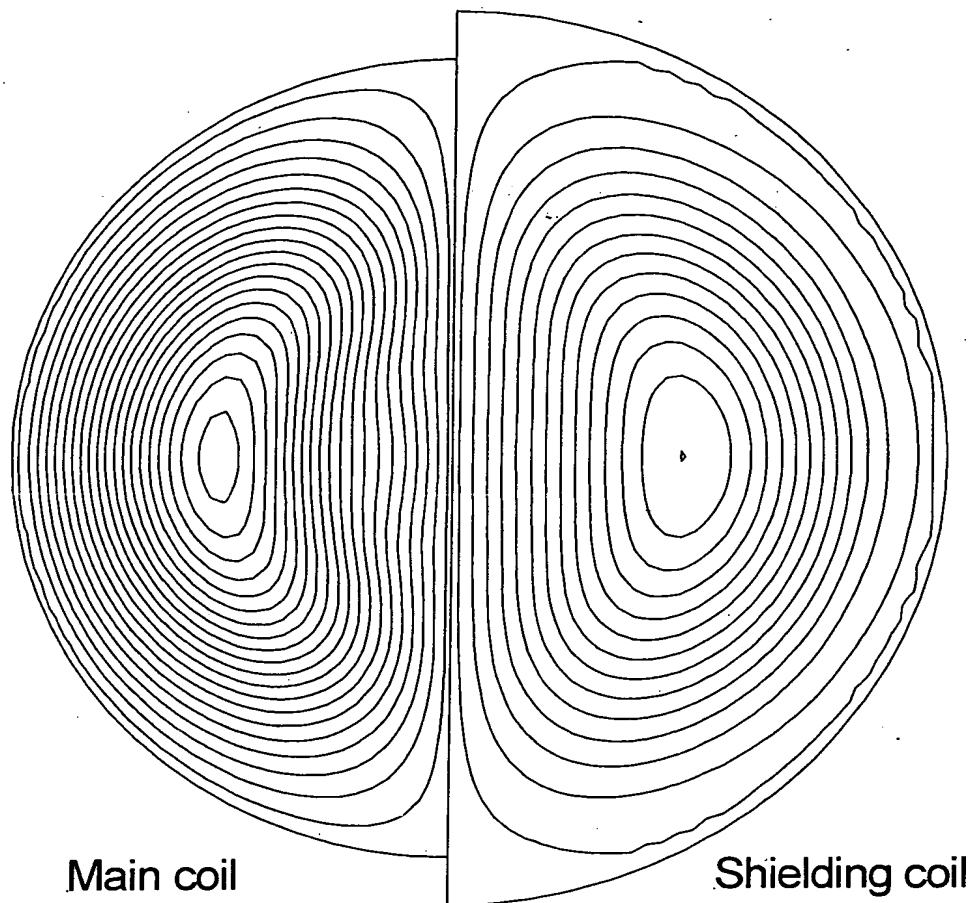


Fig.1a: Cross-section of conventional bi-planar gradient coil



**Fig.1b: Winding patterns of conventional bi-planar gradient coil (X axis)
(one out of four windings shown in each case)**



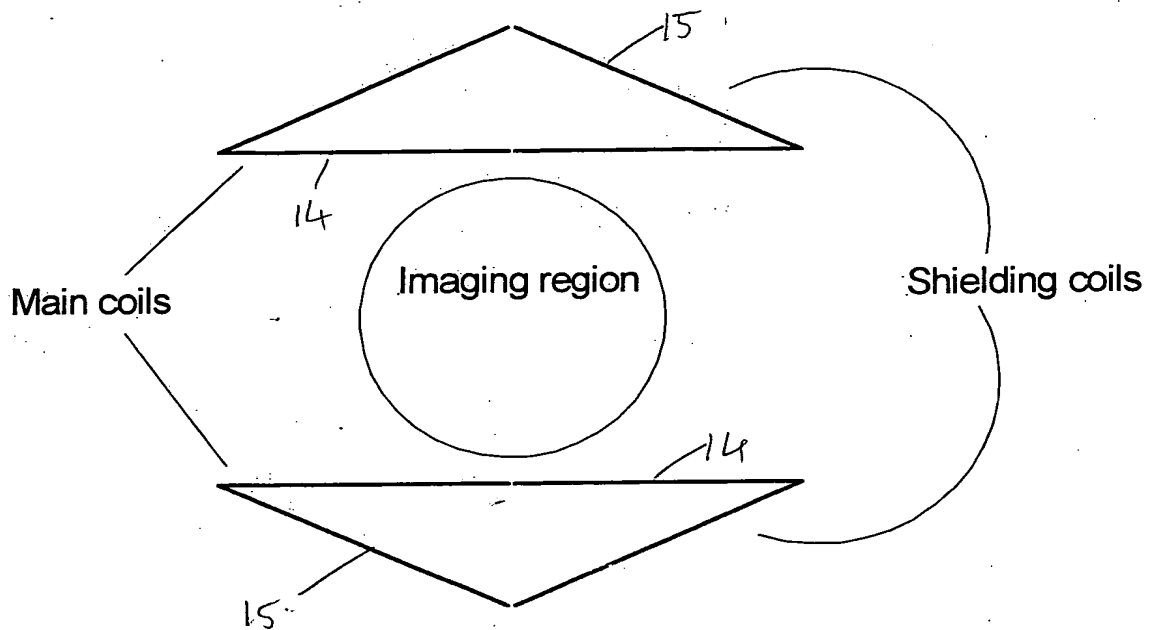


Fig.2a: Cross-section of bi-planar main gradient coil with conical shielding coil

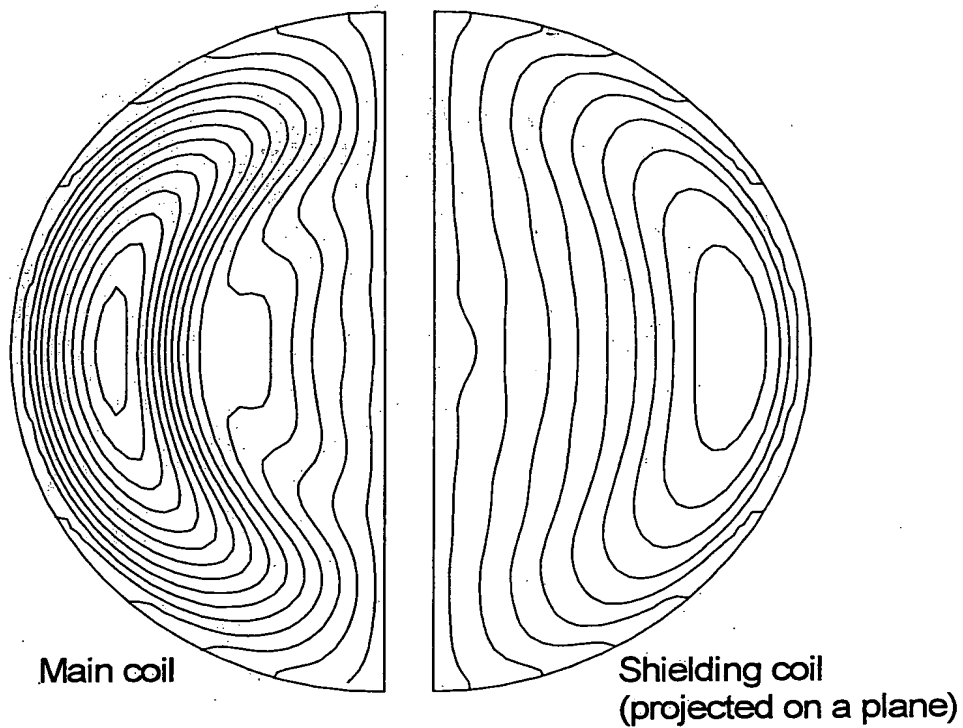


Fig.2b: Winding patterns of bi-planar main gradient coil with conical shielding coil (one of four for each), showing partial turns

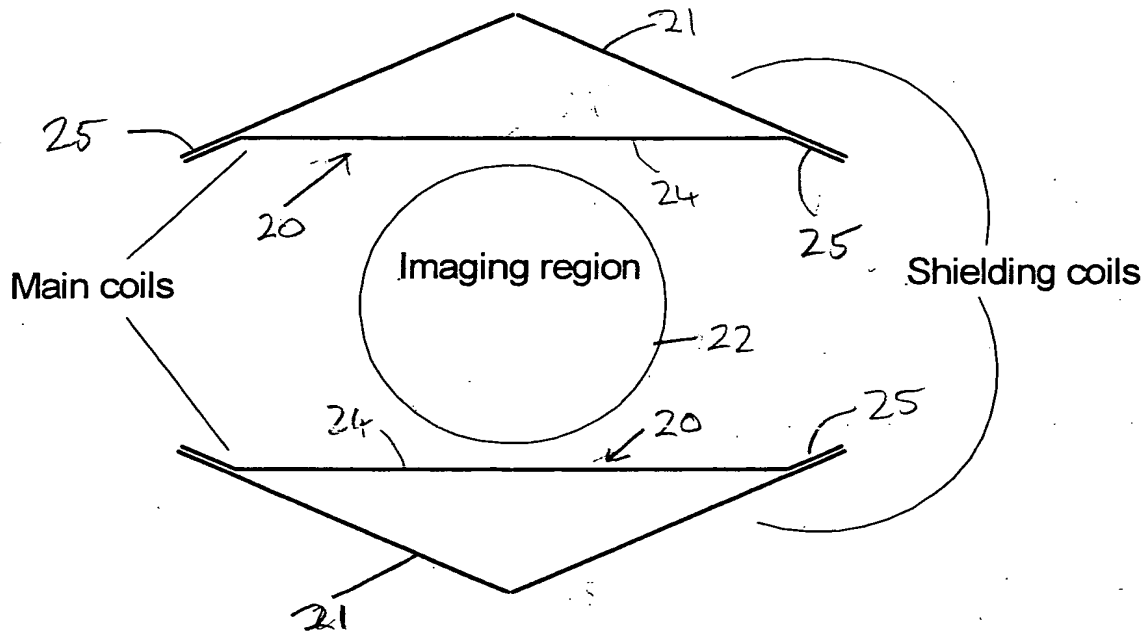


Fig.3a: Cross-section of bi-planar main gradient coil with conical shielding coil

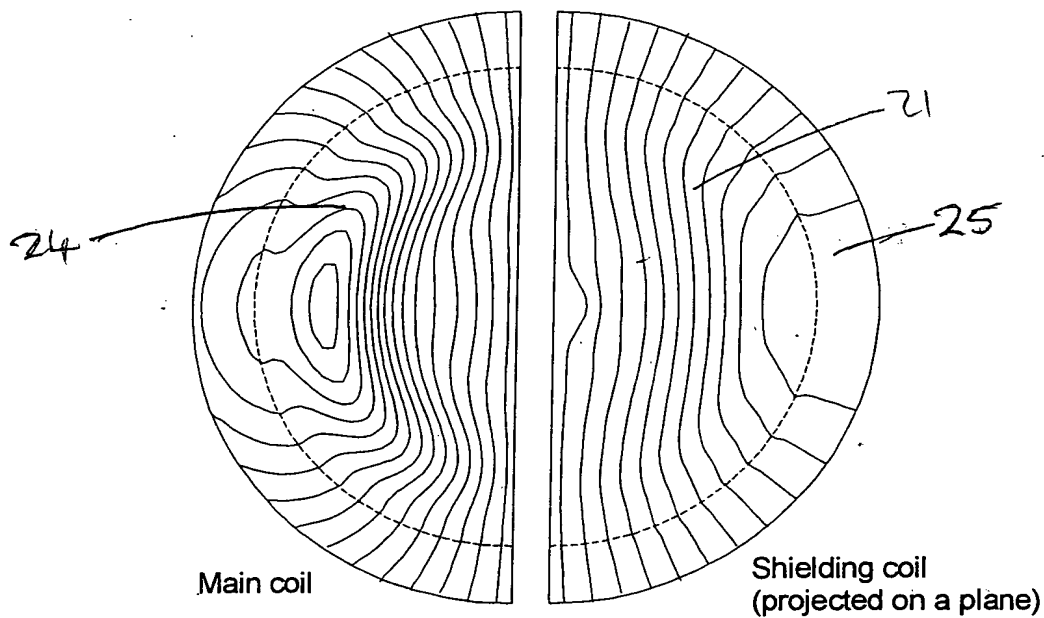


Fig.3b: Winding patterns of concave main gradient coil with conical shielding coil (one of four for each), showing partial turns. Dotted line indicates near-coincident region

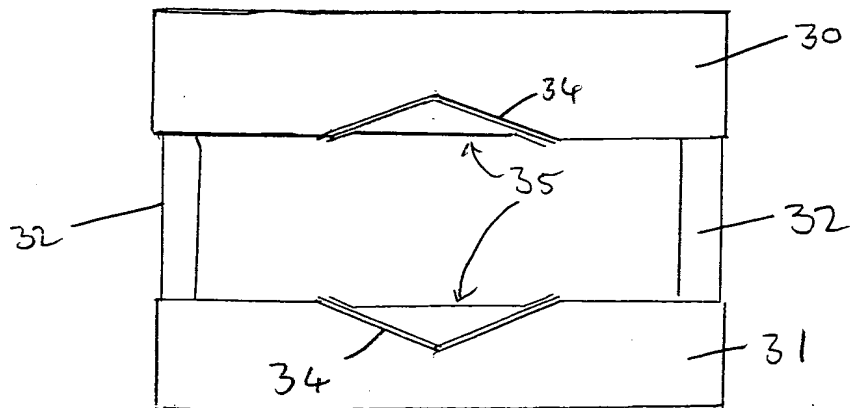


FIGURE 4

